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FORM PTO-149 MODIFIED

EXAMINER: Initial if citation considered who not in conformance and not considered. Including

Docket No.: 2437.09US04 Application No.: 10/077,180

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

APPLICANT: HIATT et al.

FILING DATE: February 15, 2002

GROUP ART UNIT: 3729

GROUP ART UNIT: 3729							
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FORM PTO-1449 MODIFIED

Docket No.: 2437.09US04 Application No.: 10/077,180

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

APPLICANT: HIATT et al.
FILING DATE: February 15, 2002

GROUP ART UNIT: 3729

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FORM PTO-1449 MODIFIED

ON APPLICANT: HIATT et al.

Application No.: 10/077,180

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

FILING DATE: February 15, 2002

Docket No.: 2437.09US04

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